

Reshetov Vladimir N. Course Schedule

MONDAY

10:15 — 11:50	■	LEC	Programming C, C ++, 🧑‍🎓 S14-601 📍 K-1006
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TUESDAY

11:55 — 13:30	■	LEC	Sensors of Physical Quantities 🧑‍🎓 S14-601 📍 45-100
16:15 — 18:40	■	SEM	Electromagnetic Compatibility (Emc) 🧑‍🎓 M15-601 📍 K-1015
18:45 — 20:20	☑	LEC	Electromagnetic Compatibility (Emc) 🧑‍🎓 M15-601 📍 K-1015
	☑	LEC	Television Systems 🧑‍🎓 S13-V01 📍 D-305
20:25 — 22:00	☑	SEM	Television Systems 🧑‍🎓 S13-V01 📍 D-305

THURSDAY

10:15 — 11:50	■	SEM	Electromagnetic Compatibility (Emc) 🧑‍🎓 S12-601 📍 K-1006
11:55 — 12:40	■	LEC	Electromagnetic Compatibility (Emc) 🧑‍🎓 S12-601 📍 K-1006
12:45 — 14:20	☑	LEC	Digital Signal Processing: Methods and Tools 🧑‍🎓 S13-601 📍 K-1017
14:30 — 17:50	☑	LAB	Digital Signal Processing: Methods and Tools 4 зан. 🗣 Subgroup 1 🧑‍🎓 S13-601 📍 K-1017
	☑	LAB	Digital Signal Processing: Methods and Tools 4 зан. 🗣 Subgroup 2 🧑‍🎓 S13-601 📍 K-1017

FRIDAY

10:15 — 11:50	☑	LAB	Assembler PC 🧑‍🎓 S12-601 📍 K-1017
11:55 — 13:30	☑	LEC	Assembler PC 🧑‍🎓 S12-601 📍 K-1017
14:30 — 17:50	☑	LAB	Programming C, C ++, 4 зан. (2017-04-07 — 2017-05-19) 🧑‍🎓 S14-601 📍 K-1017

SATURDAY

08:30 — 10:05	■	SEM	Electromagnetic Compatibility (Emc) (2017-04-01 — 2017-05-20) 🧑‍🎓 S13-601 📍 K-805
10:15 — 11:50	☑	SEM	Measuring of Electromagnetic Process Parameters 🧑‍🎓 M16-602, S13-601 📍 K-805
	☑	SEM	Measuring of Electromagnetic Process Parameters 🧑‍🎓 M16-602, S13-601 📍 K-805
12:45 — 16:05	☑	LAB	Sensors of Physical Quantities 4 зан. 🧑‍🎓 S14-601 📍 K-1015
	☑	LAB	Measuring of Electromagnetic Process Parameters 4 зан. 🗣 Subgroup 1 🧑‍🎓 S13-601 📍 K-1015
	☑	LAB	Measuring of Electromagnetic Process Parameters 4 зан. 🗣 Subgroup 2 🧑‍🎓 S13-601 📍 K-1015